



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hans Wilfried Peter Koops  
Klaus Edinger

Title: **PROCEDURE FOR ETCHING OF MATERIALS AT THE SURFACE  
WITH FOCUSSED ELECTRON BEAM INDUCED CHEMICAL  
REACTION AT SAID SURFACE**

Application Serial No. : 10/628,174

Filing Date: July 28, 2003

Assignee: NaWoTec GmbH

Priority claimed: October 16, 2002, European Patent No. 02 023 217.9

**AMENDMENT**

This amendment is in response to Office Action dated October 14, 2005. A petition for a two month extension and fee is being submitted herewith. Reconsideration of claims 1-3 and 19-41 is respectfully requested.

Petition is hereby made for a two-month extension of the period to respond to the outstanding Official Action. A check in the amount of \$450.00, as the Petition fee, is enclosed herewith. If there are any additional charges, or any overpayment, in connection with the filing of the amendment, the Commissioner is hereby authorized to charge any such deficiency, or credit any such overpayment, to Deposit Account 23-3060.

03/17/2006 WABDEL R1 00000077 10628174

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450.00 DP

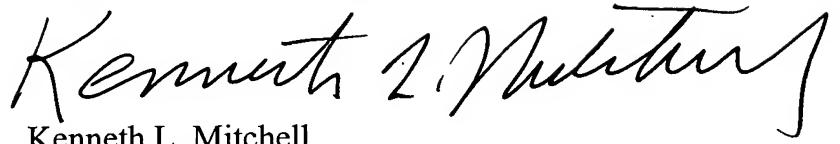
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Respectfully submitted,

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